

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant : David L. Chapek
Serial No. : 09/605,293
Filed : June 28, 2000
Title : SEMICONDUCTOR DEVICES INCLUDING A LAYER OF
POLYCRYSTALLINE SILICON HAVING A SMOOTH
MORPHOLOGY
Docket No. : MIO 0037 VA
Examiner : Landau, Matthew C
Art Unit : 2815
Confirm. No. : 5927

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

EFS Web Electronic Submission
January 23, 2008

RESPONSE TO NOTICE OF NON-COMPLIANT
AMENDMENT (37 CFR 1.121)

This paper is being filed in response to the Notice of Non-Compliant Amendment mailed January 18, 2008 which indicated that a complete listing of all of the claims is not present. In accordance with 37 CFR 1.121, Applicant is resubmitting a corrected listing of claims which includes canceled claims 1-8 and 13.